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S&N 10/005667

<u>PATENT</u>
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Qing Ma

Examiner: Jamie Brophy

Serial No.:

10/005667

Group Art Unit: 2822

Filed:

November 2, 2001

Docket: 884.591US1

Title:

METHOD OF FABRICATING AN INTEGRATED CIRCUIT HAVING A

MEMS DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents Washington, D.C. 20231

In response to the Restriction Requirement mailed January 27, 2003, Applicant elects, with traverse, Group I (claims 1-22). If the restriction is continued, Applicant cancels remaining claims 23-28, without prejudice or disclaimer, and reserves the right to reintroduce them in one or more divisional applications at a later date.

The Restriction Requirement is traversed on the basis that Restriction Requirements are optional in all cases. MPEP 803. If the search and examination of an entire application can be made without serious burden, the Examiner must examine it on the merits, even though it arguably may include claims to distinct or independent inventions. MPEP 803. All of the pending claims relate to integrated circuits and methods that include a MEMS device in a sealed cavity. Thus, Applicant respectfully submits that these claims can all be easily searched and examined together.

The Examiner is invited to contact Applicant's Representative Andrew Peret at 262/646-7009 or the below signed attorney if there are any questions regarding this Response or if prosecution of this application may be assisted thereby.

Respectfully submitted,

QING MA

By his Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

P.O. Box 2938

Minneapolis, MN 55402

612-349-9592

Date Feb. 26 2003

By ann M. Mc Cach

Ann M McCrackin Reg. No. 42,858

Anne M. Richards

Name

Ciama Ciama